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1774

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q61200

Hiroshi OGAWA, *et al.*

Appln. No.: 09/810,230

Group Art Unit: 1774

Confirmation No.: 6907

Examiner: Camie S. THOMPSON

Filed: March 19, 2001

For: RADIATION IMAGE CONVERSION PANEL AND MANUFACTURING METHOD
THEREFOR

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of two months, extending the time for responding to the Office Action of February 17, 2005, to July 18, 2005.

A check for the statutory fee of \$450.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

07/19/2005 JADD01 00000033 09810230

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450.00 OP

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Respectfully submitted,

L. Raul Tamayo
Registration No. 47,125

Date: July 18, 2005